INITED STATES PATENT AND TRADEMARK OFFICE

	10/695,726
Filing Date	October 28, 2003
Inventor	Ross S. Dando et al.
	Micron Technology, Inc.
	Karla A. Moore
Attorney's Docket No	MI22-2432
Customer No	
Title:	Chemical Vapor Deposition Apparatus

RESPONSE TO SEPTEMBER 20, 2005 FINAL OFFICE ACTION TO ACCOMPANY RCE FILING

To:

Mail Stop RCE

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

VIA U.S. EXPRESS MAIL

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)

Wells St. John P.S.

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Responsive to the Office Action dated September 20, 2005, Applicant amends and remarks as follows:

<u>AMENDMENTS</u>

12/14/2005 DEMMANU1 00000037 10695726

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